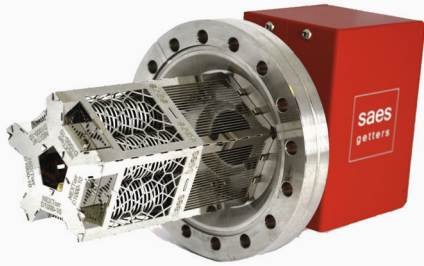


NEXTorr® D 1000-10



HIGHLIGHTS

General Features

- > Extremely compact and low weight
- > High and constant pumping speed for all active gases in UHV-XHV
- > Pumping speed for noble gases and methane
- > Long lasting in UHV-XHV
- > Negligible power consumption in operation
- > Reduced magnetic interference
- > Able to indicate system pressure
- > Maintenance-free

Applications

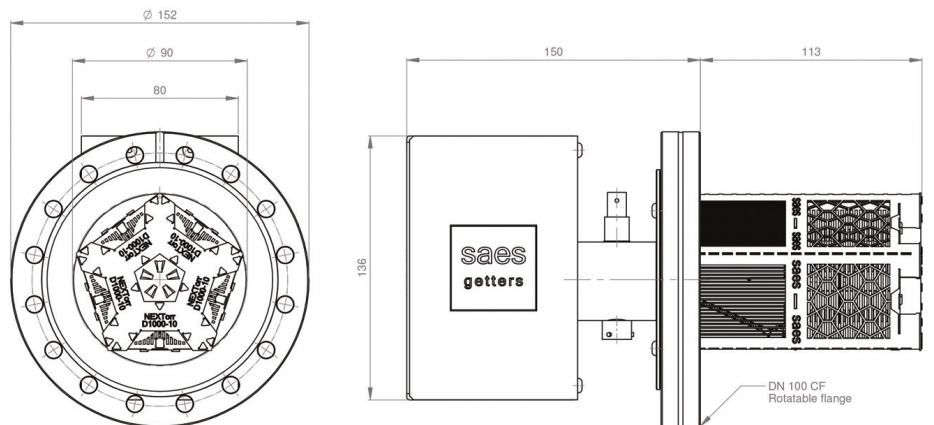
- > Improvement of the ultimate vacuum in UHV-XHV systems
- > Particle accelerators, synchrotron radiation sources
- > Atom/Ion Trap systems, atomic clocks/fountains, interferometers
- > Scanning /Transmission electron microscopes
- > Portable vacuum instrumentation and suitcases
- > Surface analysis systems
- > General purpose UHV systems

The NEXTorrr® D 1000-10 is a compact Ultra High Vacuum pump that efficiently integrates a sputter ion pump (SIP) and a Non Evaporable Getter (NEG) pump into a vacuum solution featuring high pumping speeds and capacities with a low weight and small footprint.

The NEG element of the NEXTorrr D 1000-10 is based on high performance sintered porous getter disks (St 172), stacked in an optimized gas trapping structure, and featuring pumping speed in excess of 1000 l/s (H₂).

The NEG cartridge is integrated onto a CF 100 flange containing a heater for the getter activation (500°C x 1 h). Once activated, the NEG will operate at room temperature without the use of power. The pump is equipped with a K-type thermocouple electrically insulated within an alumina tube for optimal temperature control during the conditioning and activation.

The opposite side of the same flange hosts a noble diode ion pump featuring 10 l/s for Ar and 32 l/s for CH₄. Gas flows from the vacuum system to the ion pump through a path optimized for conductance. The design of the pump provides additional pumping synergies: gases eventually released by the ion pump during operation are intercepted and removed by the NEG element, thus minimizing back-streaming effects; even fine Titanium particles, known to be potentially emitted by ion pumps, are effectively trapped by the NEG, reducing the risk of contamination of the vacuum system.

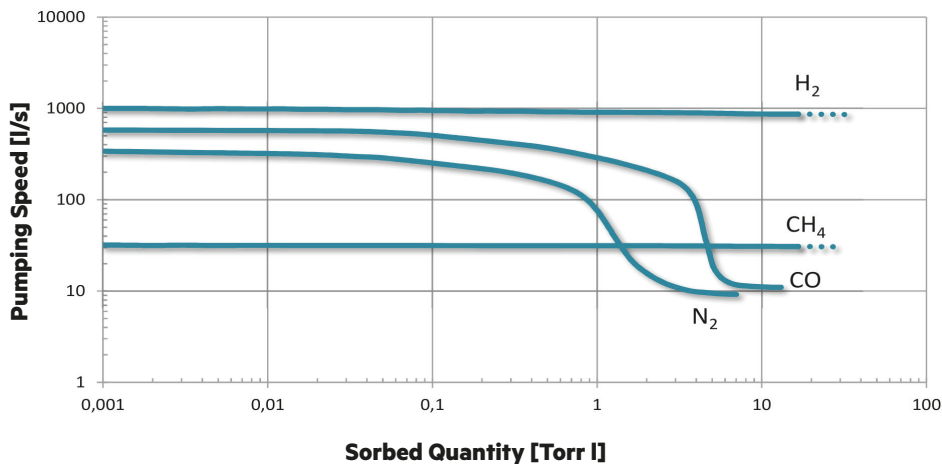


Dimension in mm

Total pump weight (magnets included)	6.5 kg
Type of pump	Diode
Flange type	CF100

NEXTorr® D 1000-10

NEXTorr D1000-10 sorption test (according to ASTM F798-97)



Initial pumping speed (l/s)	Gas	NEG activated	NEG saturated
	H ₂	1000	13
	H ₂ O ¹	850	9
	CO	580	11
	N ₂	320	9
	CH ₄	32	
	Argon ²	10 (2.5)	
Sorption capacity (Torr·l)	Gas	Single-run capacity ^{3,4}	
	H ₂	1125	
	H ₂ O ¹	440	
	CO	7	
	N ₂	4	
	CH ₄	50,000 hours at 10 ⁻⁶ Torr	
NEG section	Getter alloy type	St 172	
	Alloy composition	Zr V Fe	
	Getter mass (g)	112.5	
	Getter surface (cm ²)	950	
	Activation power (W) ⁵	220	
Ion section	Voltage applied	DC +5 kV	

¹ The values for H₂O are estimated.

² Measured at 3x10⁻⁶ Torr. Unsaturated ion pump (saturated ion pump).

³ Single-run capacity is reached when pumping speed is equal to the pumping speed of the ion element only (this limit does not apply for H₂).

⁴ > 100 reactivations (sorption cycles) are possible.

⁵ It is referred to the "nude" configuration (NEG element completely immersed in the vacuum chamber).

Ordering information

Product	Product description	Code
NEXTorr Pump	NEXTorr D 1000-10	5H0180
Pump controller	NEXTorr PS NIOPS-06 [#]	3B0440
Control cables	NEXTorr kit of cables 04-06 [§]	3B0416

(#) It is also possible to order split controllers: NEG POWER for the NEG element (available in various models able to simultaneously activate up to four pumps), and SIP POWER for the ion element.

(§) The kit includes 3 m long cables. Longer cables are available on request.

The SAES manufacturing companies are ISO9001 certified, the Asian and Italian companies are also ISO14001 certified.

Full information about our certifications for each company of the Group are available on our website at:

www.saesgroup.com

D.VS.116.6.24

The NEXTorr® product line incorporates and exploits the patented concept of a combined pumping system comprising a getter pump and an ion pump, and have global Intellectual Property Rights coverage with patents already granted in the US (8,287,247), Europe (2,409,034), Japan (5,372,239), China (102356236).

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